

Design and FEA simulations of pressure withstanding PMT encapsulations for LENA

and

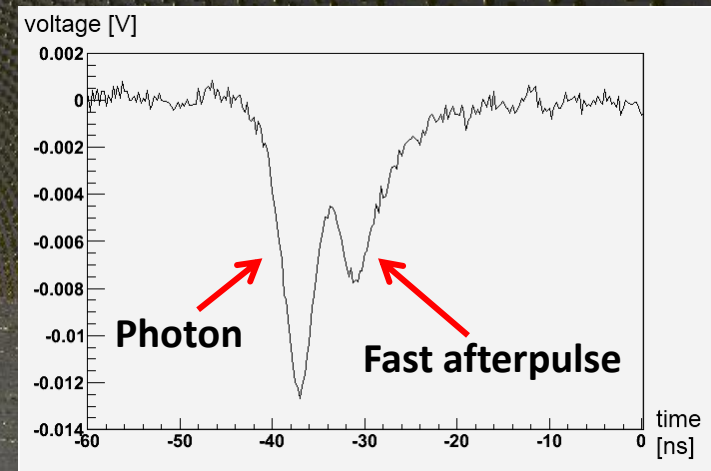
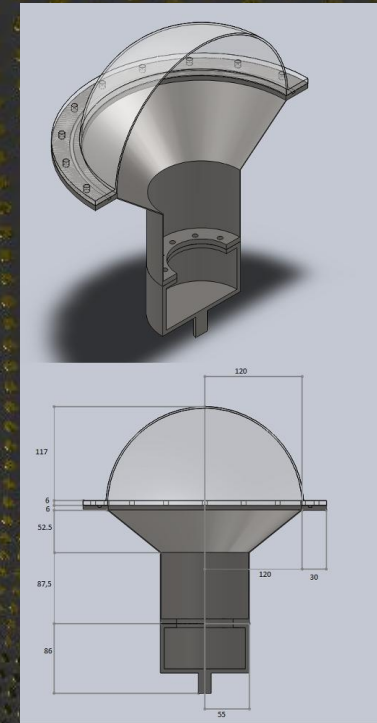
Algorithms to identify fast afterpulses on a previous pulse

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Light2011, Ringberg

2011/10/31



Overview

Pressure withstanding PMT encapsulations for LENA

- Why encapsulate PMTs?
- Design
- Finite Elements Analysis simulations + results
- Next steps

Fast Afterpulses in PMTs + SiPMs

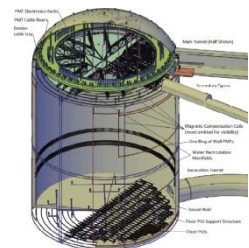
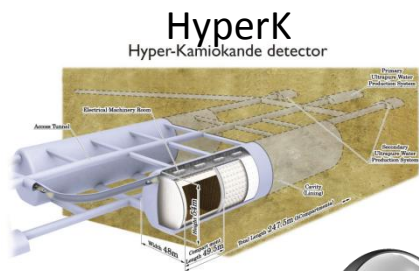
- Causes
- Reasons to study them
- Algorithms to detect fast Afterpulses on the flank of a previous pulse

Summary



Pressure withstanding PMT
encapsulations for LENA

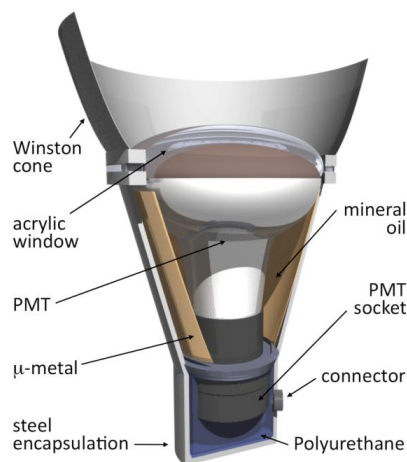
Pressure withstanding PMT encapsulations for LENA: Why encapsulate PMTs?



LBNE



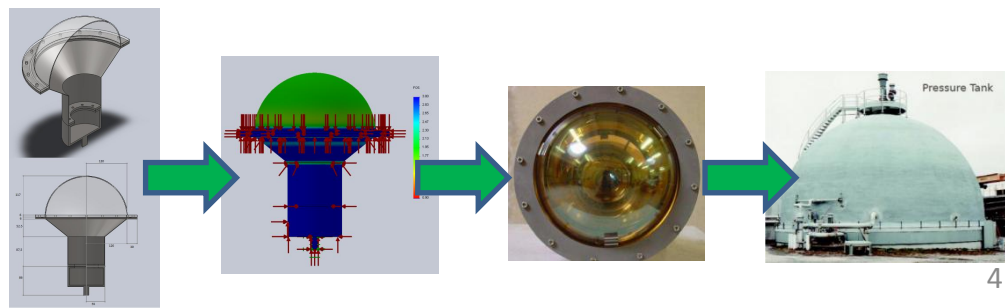
LENA



- Next-generation land-based neutrino experiments like HyperK, LBNE or LENA use tanks with heights of 50-100m
→ High pressure at the tank bottom
 - LENA: $\approx 9.8\text{bar(LAB)}$ + safety margin
→ At the moment no available PMT model fulfills requirements



- a) Develop new PMTs (LBNE)
- **b) House PMTs in encapsulations (LENA)**
 - ➕ No restrictions on PMT model to be used
 - ➕ Cheaper?
 - ➕ Faster development
 - ➕ LENA: certainly possible to fulfill requirements
 - ➖ Introduce radioactivity

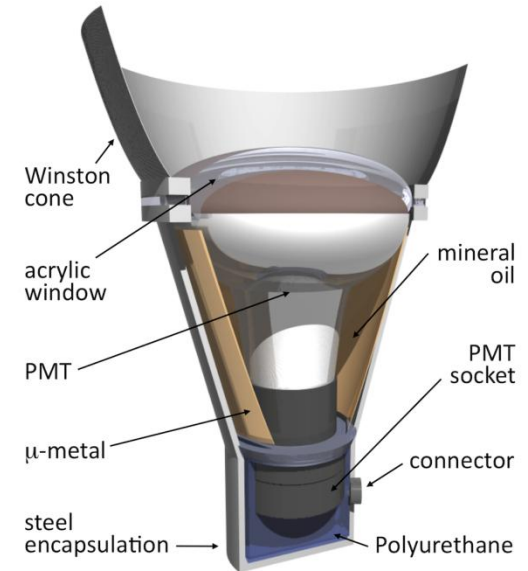


How to develop an encapsulation?

- *Design, pressure simulations, build prototype, pressure tests*

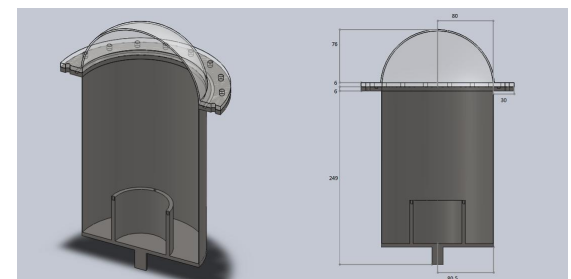
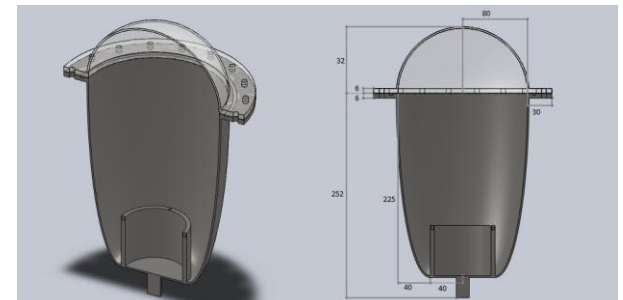
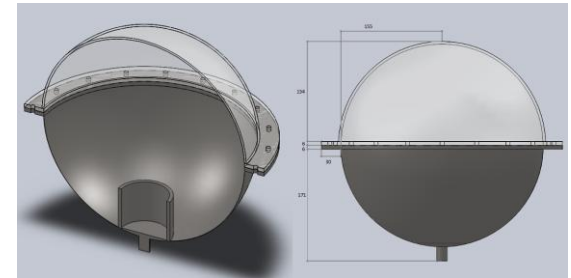
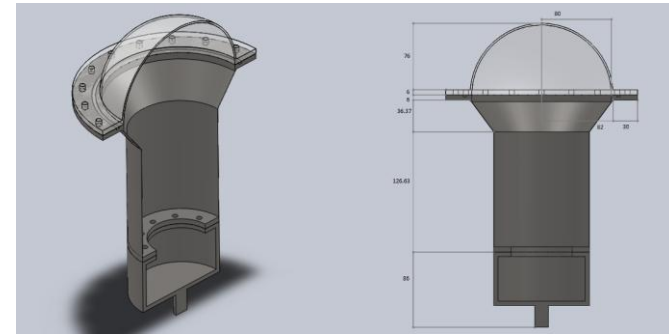
Pressure withstanding PMT encapsulations for LENA: Design

- Configuration
 - Acrylic glass transparent window
 - Stainless steel body housing, one or two parts
 - Also incorporate Mu-metal, Winston Cone and connection to other PMTs + tank
 - *not crucial for pressure simulations → at a later date*
- Different encapsulation designs
 - Conical
 - based on Borexino + Double Chooz encapsulation
 - Spherical
 - as in deep sea neutrino telescopes / IceCube
 - Elliptical
 - Cylindrical
- Create engineering drawings with CAD software:
 - [SolidWorks Educational Edition Academic Year 2010-2011 SP4.0](#)



Pressure withstanding PMT encapsulations for LENA: Design

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Pressure withstanding PMT encapsulations for LENA: Pressure simulations

- Simulate behaviour under pressure with a Finite Elements Analysis (FEA) simulation software
 - Engineering drawings and FEA pressure simulations were done with same software
- Software: SolidWorks Educational Edition Academic Year 2010-2011 SP4.0, *Simulation Premium package*
- Settings: Linear static study, 12bar pressure, node distance 3mm ± 0.15mm
- Materials: High impact resistant acrylic glass, 1,4404 stainless steel X2CrNiMo17-12-2
- Computer: Intel i7-2600, 8GB DDR3-RAM, AMD Radeon HD 6450 1GB GDDR3, Win7 Prof. 64bit
- So far designs + simulations for 5 candidate PMTs:
 - Hamamatsu: R7081 (10"), R5912 (8"), R6594 (5")
 - Electron Tubes Enterprises Ltd.: 9354 (8"), 9823 (5")
- Was treated in a bachelor thesis by **German Beischler**
 - In consultance with **Harald Hess** (head of workshop + SolidWorks expert of our chair)
 - Continues these studies!



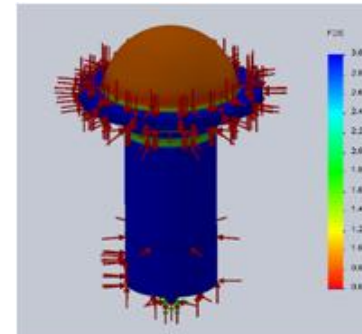
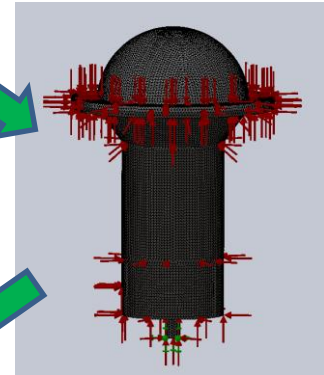
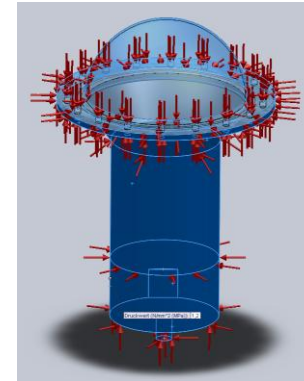
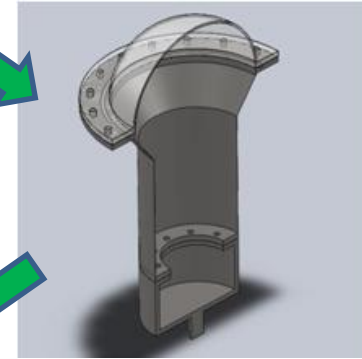
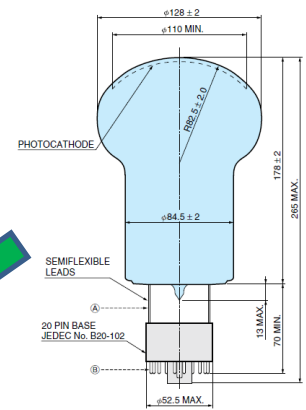
German Beischler

Pressure withstanding PMT encapsulations for LENA:

Pressure simulations

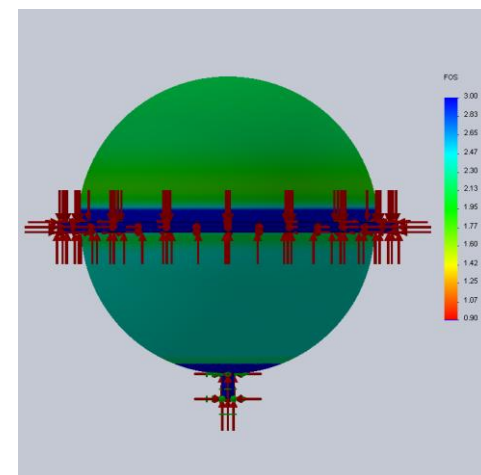
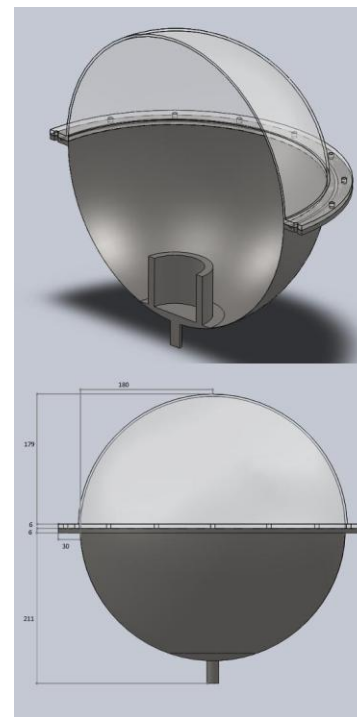
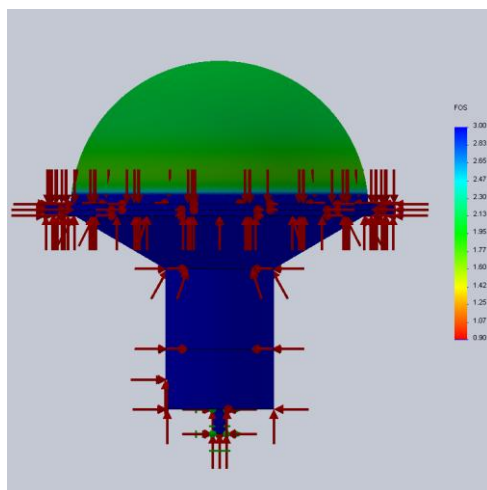
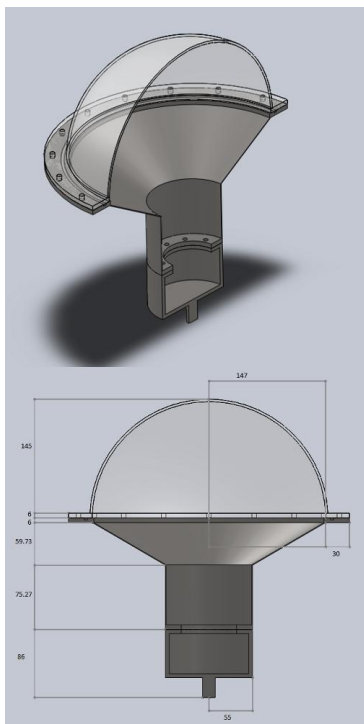
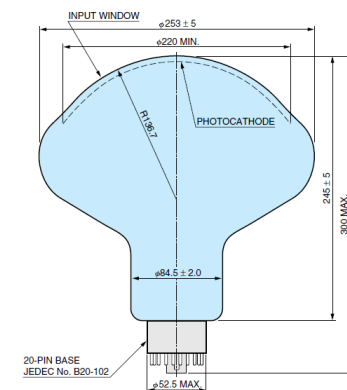
Procedure:

- Import PMT contour from engineering drawing in datasheet
- Rotate to obtain model of PMT
- Construct encapsulation based on PMT dimensions and experience from design of the Borexino + Double Chooz encapsulation
- Simulate encapsulation with 12bar pressure applied
 - Apply forces → meshing → simulate to determine factor of safety
 - Vary thicknesses of acrylic glass + stainless steel to find minimum values
- Compare results for different designs regarding weight (U, Th, K impurities in materials), surface (adsorbed Rn) and construction costs



Pressure withstanding PMT encapsulations for LENA

Pressure simulation results: Hamamatsu R7081 (10")



Conical encapsulation:

Steel: 2mm thickness, 4.38kg
 Acrylic glass: 4mm thickness, 0.86kg
 Total surface: 0.69m²

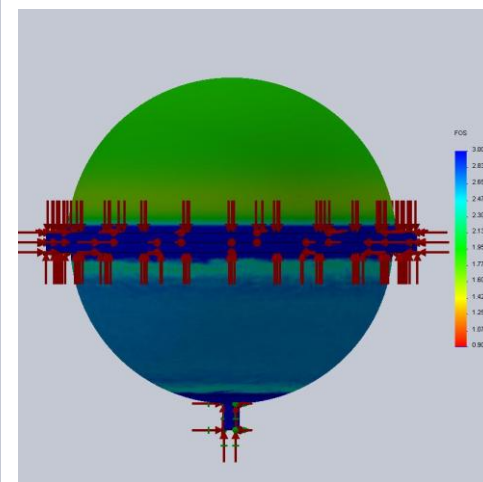
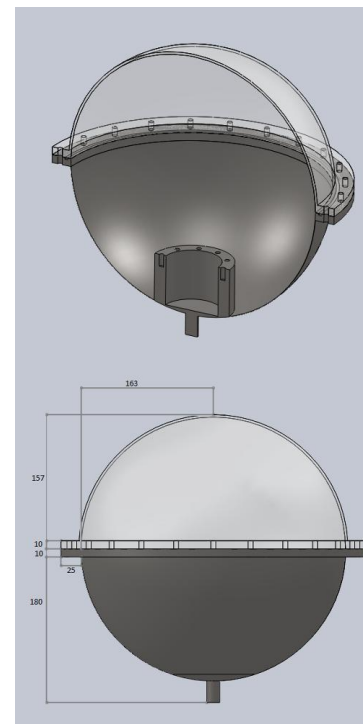
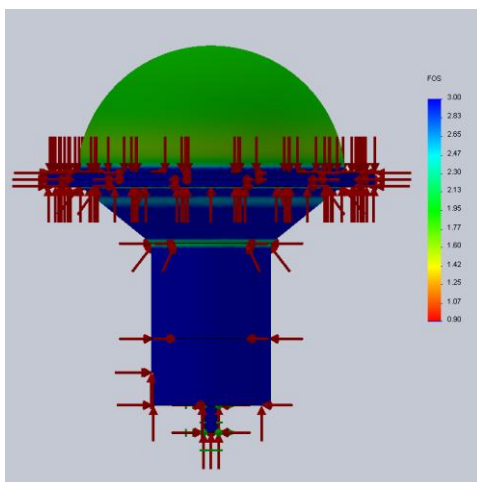
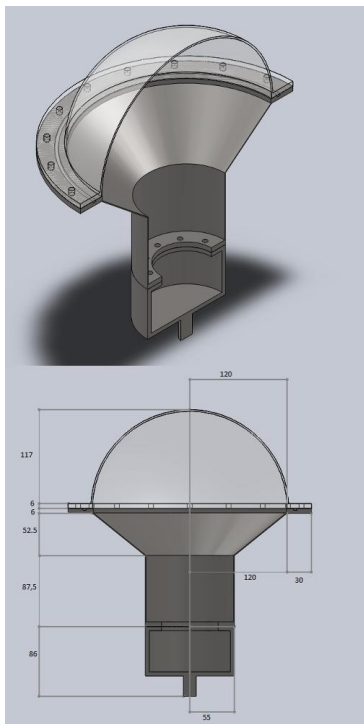
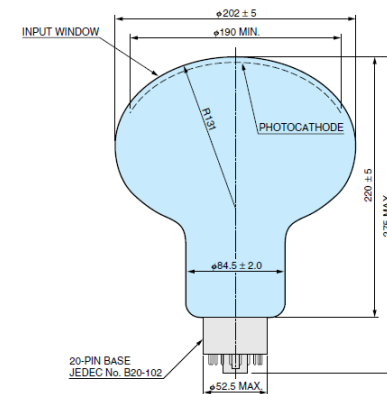
Spherical encapsulation:

Steel: 0.5mm thickness, 4.08kg
 Acrylic glass: 5mm thickness, 1.48kg
 Total surface: 1.01m²

Pressure withstanding PMT encapsulations for LENA

Pressure simulation results:

Hamamatsu R5912 (8")



Conical encapsulation:

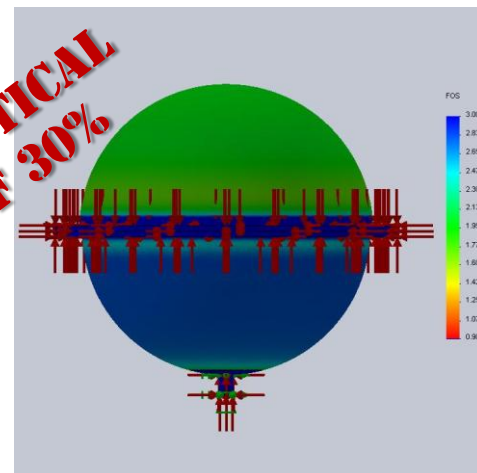
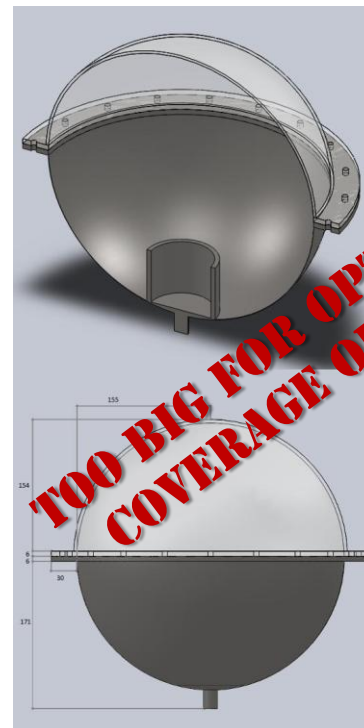
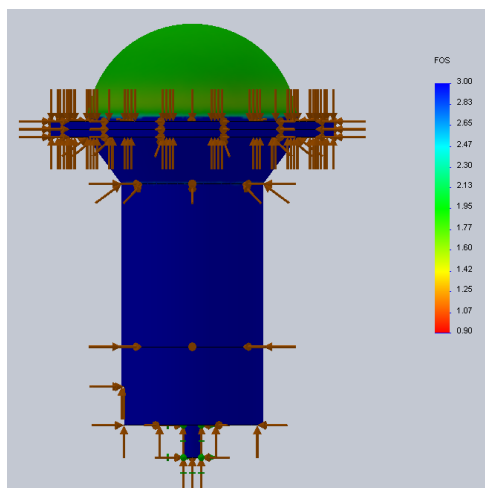
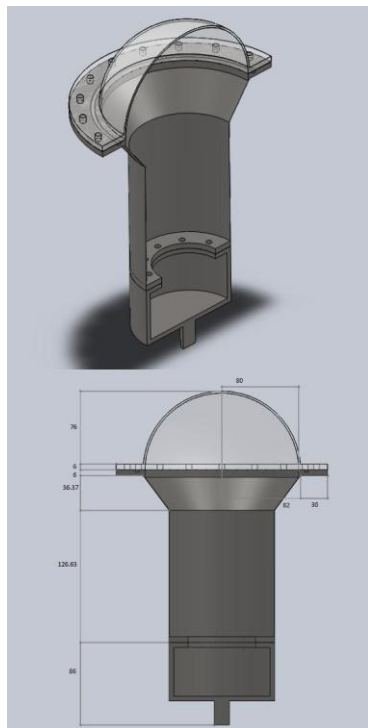
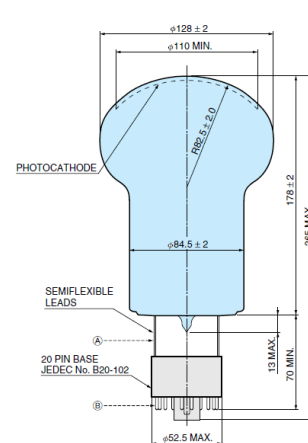
Steel: 1mm thickness, **3.24kg**
 Acrylic glass: 3mm thickness, **0.50kg**
 Total surface: **0.53m²**

Spherical encapsulation:

Steel: 0.5mm thickness, **4.66kg**
 Acrylic glass: 4mm thickness, **1.10kg**
 Total surface: **0.83m²**

Pressure withstanding PMT encapsulations for LENA

Pressure simulation results: Hamamatsu R6594 (5")



**TOO BIG FOR OPTICAL
COVERAGE OF 30%**

Conical encapsulation:

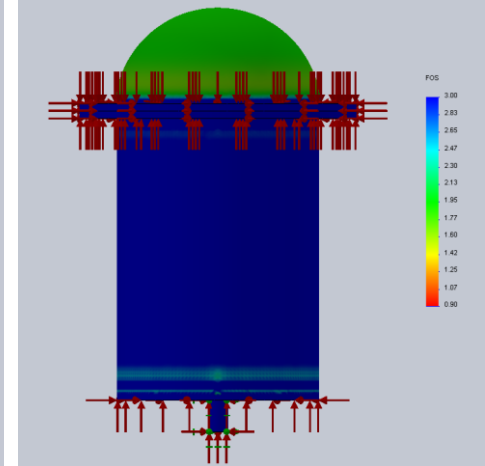
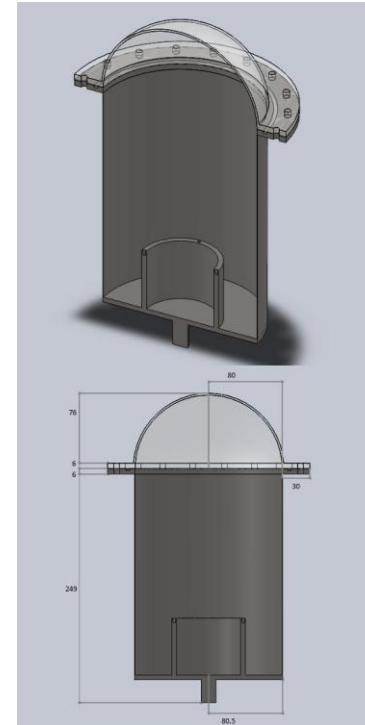
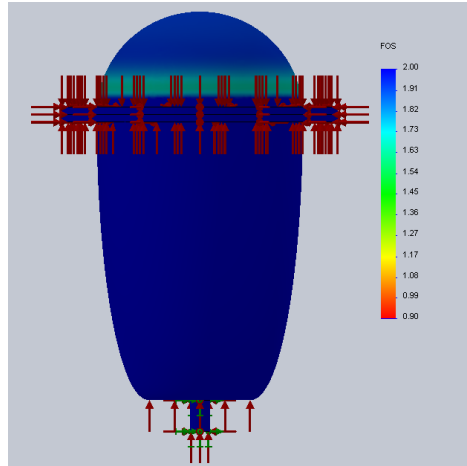
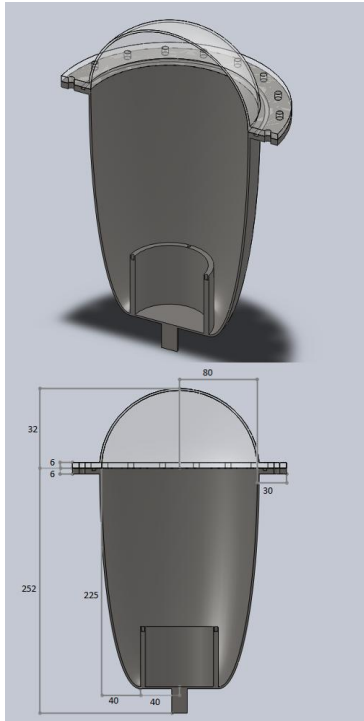
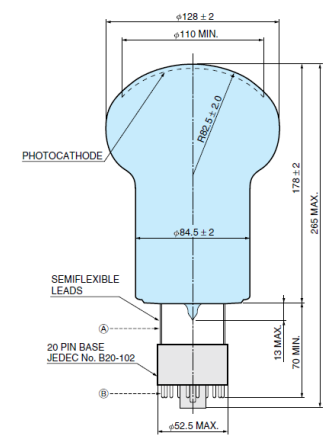
Steel: 1mm thickness, 2.77kg
 Acrylic glass: 2mm thickness, 0.22kg
 Total surface: 0.37m²

Spherical encapsulation:

Steel: 0.5mm thickness, 2.75kg
 Acrylic glass: 4mm thickness, 0.94kg
 Total surface: 0.78m²

Pressure withstanding PMT encapsulations for LENA

Pressure simulation results: Hamamatsu R6594 (5")



Elliptical encapsulation:

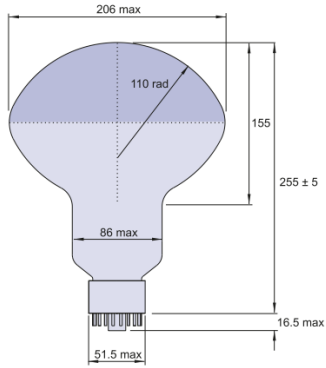
Steel: 2mm thickness, **3.06kg**
 Acrylic glass: 2mm thickness, **0.22kg**
 Total surface: **0.41m²**

Cylindrical encapsulation:

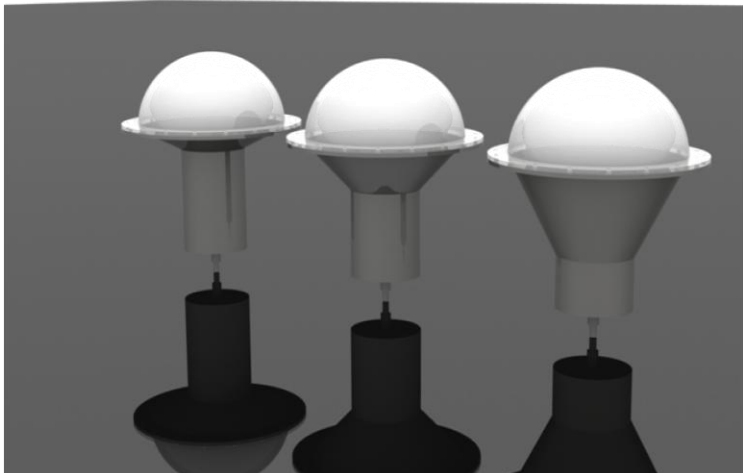
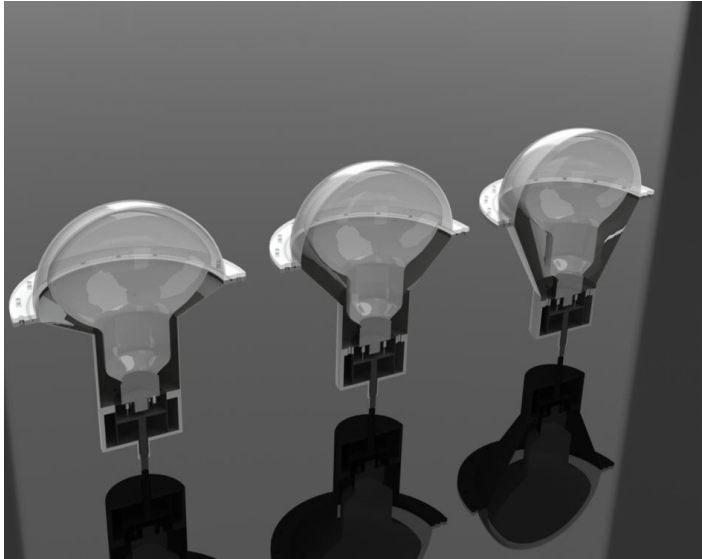
Steel: 0.5mm thickness, **2.61kg**
 Acrylic glass: 2mm thickness, **0.22kg**
 Total surface: **0.46m²**

Pressure withstanding PMT encapsulations for LENA

Pressure simulation results: ETEL 9354 (8")



- For R5912 (8") conical encapsulation was most promising → detailed study for this type for ETEL 9354
- Minimize weight in dependance of height of conical section
 - Thickness steps reduced to 0.1mm, for most lightweight encapsulation 0.01mm
 - Weight minimal for maximum length of conical part



Height of conical section [mm]	Minimal steel mass [kg]	Minimal acrylic glass mass [kg]	Total surface [m ²]
33	3.45	0.44	0.535
54	3.20	0.43	0.534
70	3.14	0.43	0.535
130	2.94	0.43	0.549

Conical encapsulation:

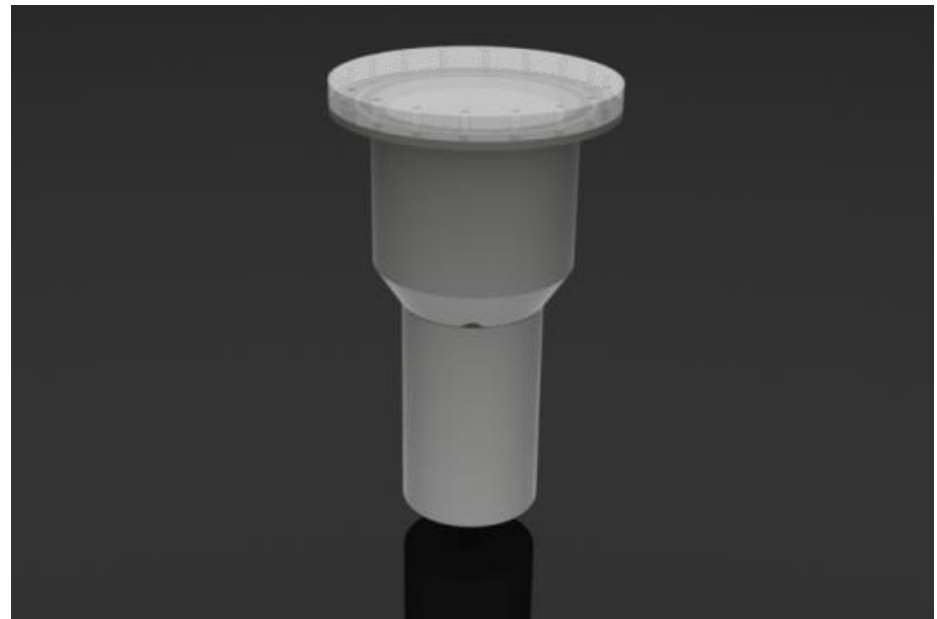
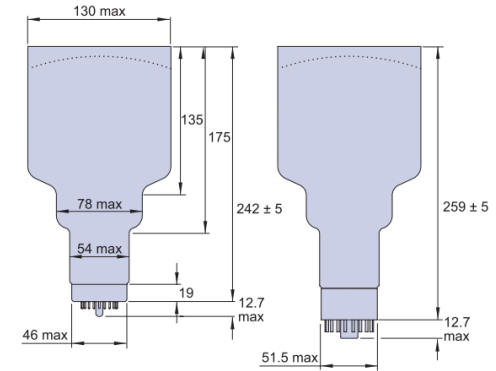
Steel: 0.45mm thickness, **2.94kg**
 Acrylic glass: 2.40mm thickness, **0.43kg**
 Total surface: **0.55m²**

Pressure withstanding PMT encapsulations for LENA

Pressure simulation results:

ETEL 9823 (5")

- Plano-concave photo cathode → try flat acrylic glass window
- Very high thickness necessary
→ Probably less material for spherical acrylic glass window needed



Conical encapsulation:

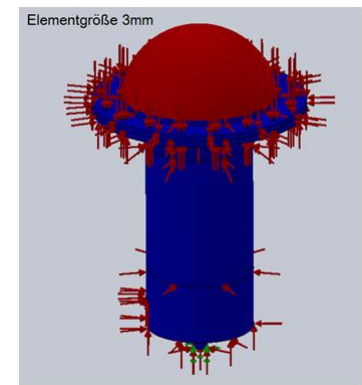
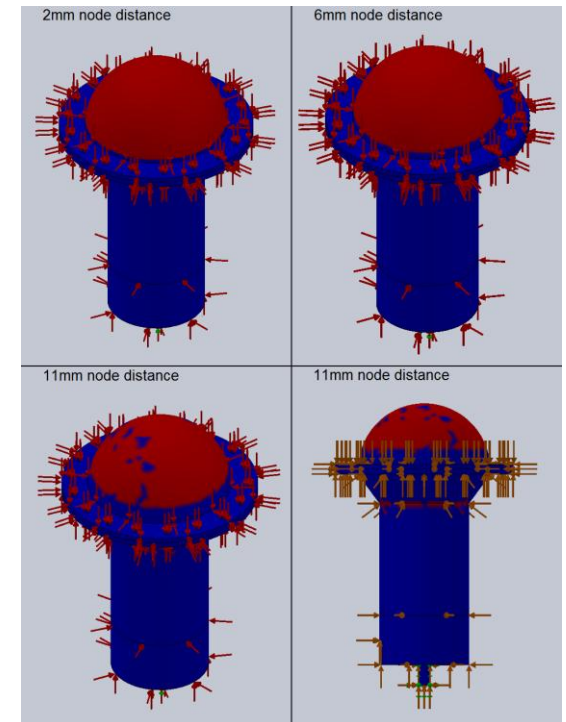
Steel: 0.6mm thickness

Acrylic glass: 17mm thickness

Pressure withstanding PMT encapsulations for LENA

Pressure simulations: cross-check of results

- Reproducibility
 - Repeated same simulation several times →
 - Same results
 - However only on fast computer - *results varied for slow computer!*
- Vary node distance from 2-11mm
 - No big change for 2mm → 3mm
 - For 11mm unphysical results
 - Where possible repeat simulation with 2mm to verify results



Factor of safety distribution:
red areas are unstable (FoS < 1)

Pressure withstanding PMT encapsulations for LENA

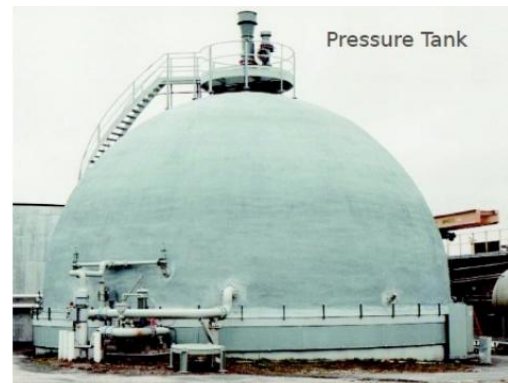
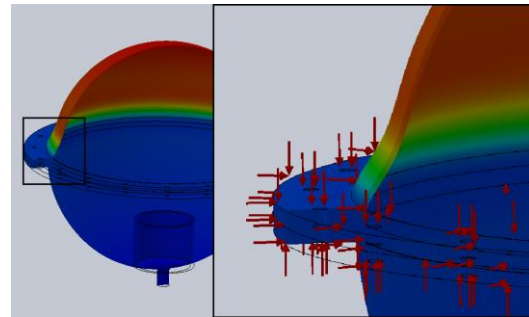
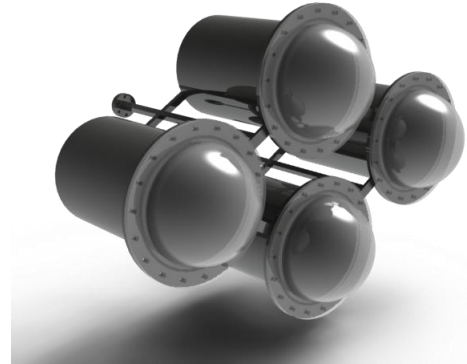
Next steps:

DESIGN +
SIMULATIONS

- Further crosschecks
- More exact simulations: reduce node distance (locally or globally), use adaptive methods
- Complete design (fixture for PMT inside encapsulation, filling valve) + create complete optical module: incorporate Mu-metal, Winston Cones, connections to other PMTs + wall
- Optimize encapsulations for least weight + least production costs
- Create + simulate designs for further PMTs (R6091, 9822, R11780, D784)
- Distortion analysis
- Aging simulation

BUILD + TEST
PROTOTYPES

- Build prototype for PMT of choice
- Test in pressure tank
 - Adapt design to meet requirements
 - Influence of PMT implosion on adjacent encapsulations

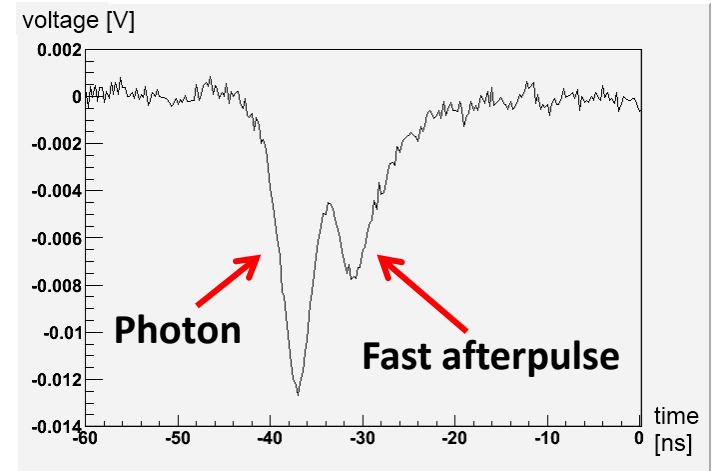




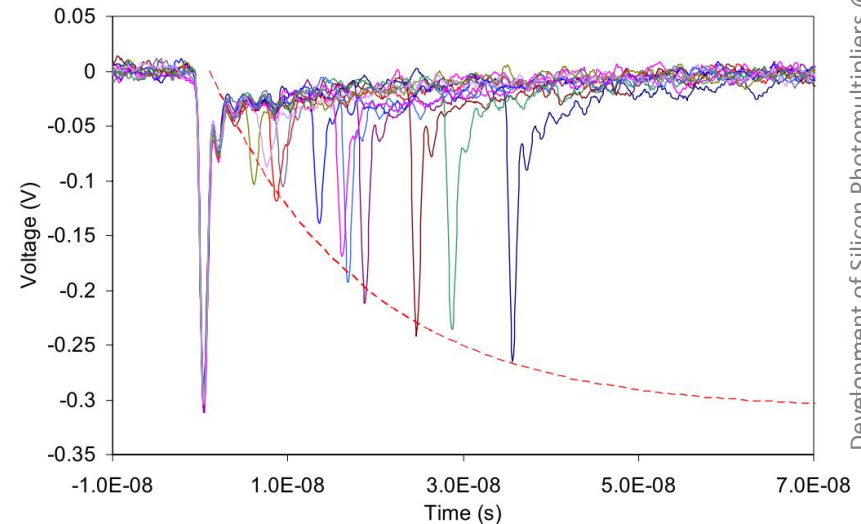
Fast Afterpulses in PMTs and SiPMs

Fast Afterpulses (fAP): Causes

- Additional pulse(s) occurring after a previous pulse within several 10 ns
- Occur in PMTs as well as SiPMs
- Possible causes:
- PMTs:
 - Light generation in PMT:
 - Bremsstrahlung at dynodes → delay $\approx \frac{1}{2}$ -1 transit time (tt)
 - Ionization / excitation
 - of residual gas molecules near anode → delay ≈ 1 tt
 - of molecules/atoms on dynodes (adsorbed/constituents) → delay $\approx \frac{1}{2}$ -1tt
 - Partial inelastic scattering of photo electron on first dynode then elastic scattering → delay ≈ 0 -1tt
- SiPM:
 - charge trapping, release time constant ~ 10 -100ns



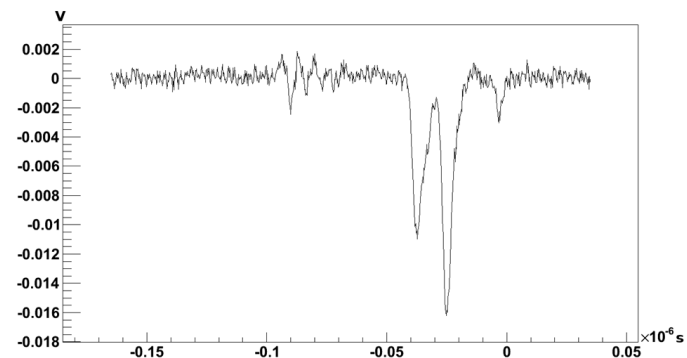
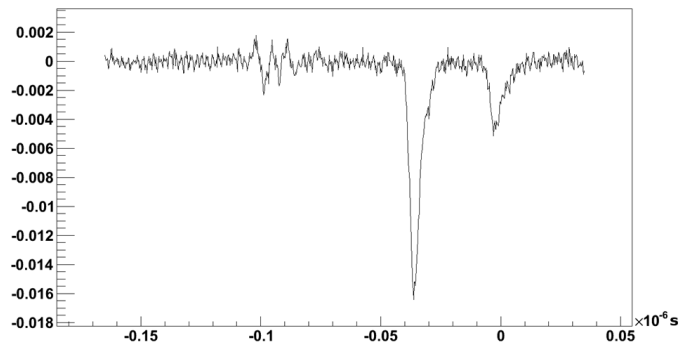
Fast Afterpulse in PMT



Fast Afterpulses in SiPM

Fast Afterpulses (fAP): Reasons to study them

- Detectors using PMTs/SiPMs: fAP influence
 - Energy resolution
 - Event reconstruction: position + time resolution, tracking
 - SiPM: with increasing overvoltage PDE, fAP probability and cross-talk increase
 - Lose single photon resolution for several photons incident at same time
 - Tradeoff between PDE and energy resolution necessary
- To be able to reduce fAP probability study fAP to understand mechanisms of production better
- To be able to analyze them first need to identify all fAP in recorded pulses
 - Easy for fAP occurring after end of original pulse
 - Difficult for fAP sitting on flank
 - Need detection algorithms to study them



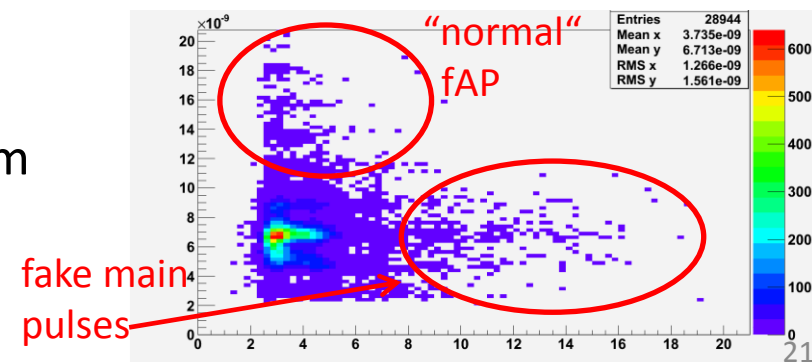
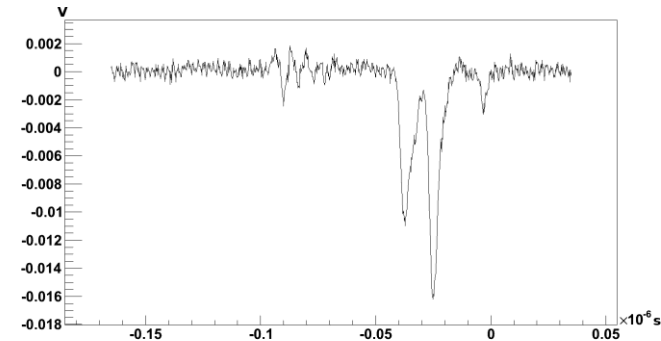
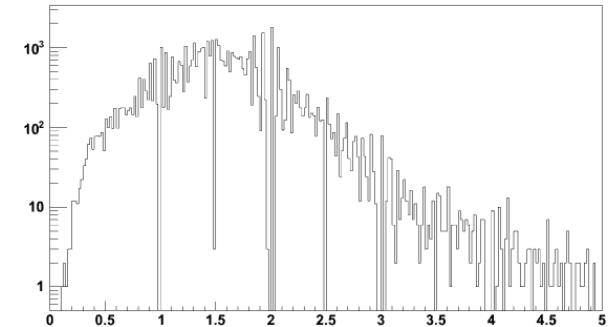
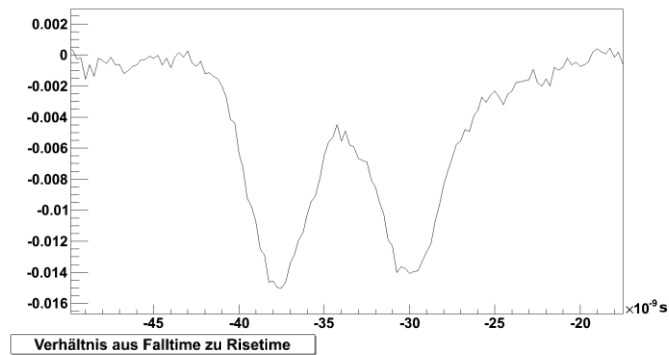
Fast Afterpulses (fAP):

Algorithms to detect fast Afterpulses on the flank of a previous pulse

- Used 50000 pulses to develop algorithms
 - Instrumentation:
 - Light source: Edinburgh Instruments EPL-405-mod, 50ps FWHM diode laser, 403nm
 - PMT: ETL 9305 (+1300V), $\approx 5.5\%$ detected pulses/laser trigger
→ $\approx 2.75\%$ 2-photon-pulses for pulses with laser-PMT coincidence
 - FADC: Acqiris DC282, used 2Ch with 4GHz sampling, 10bit
 - Sampled 1500 pulses by eye →
 - $\approx 4.9\%$ fAP on flank of main pulse
 - $\approx 2.1\%$ after main pulse within 70ns
- Different classes based on recognition criteria:
 - Time
 - Pulse shape
 - Area
- *Was treated in a Bachelor thesis by **Martin Zeitlmair***

Fast Afterpulses (fAP): Detection algorithms: Time

- Ratio fall time/rise time
 - Principle: fAP on falling flank \rightarrow time until pulse falls below 10% of pulse height is increased
 - Problems:
 - **Fake main pulses**: if fAP maximum $>$ main pulse maximum, fAP is detected as pulse maximum \rightarrow ratio too low
- Conclusion:
 - No strong separation visible
 - Can be used for big ratios
 - Use as cross-check after other algorithm for fake main pulses

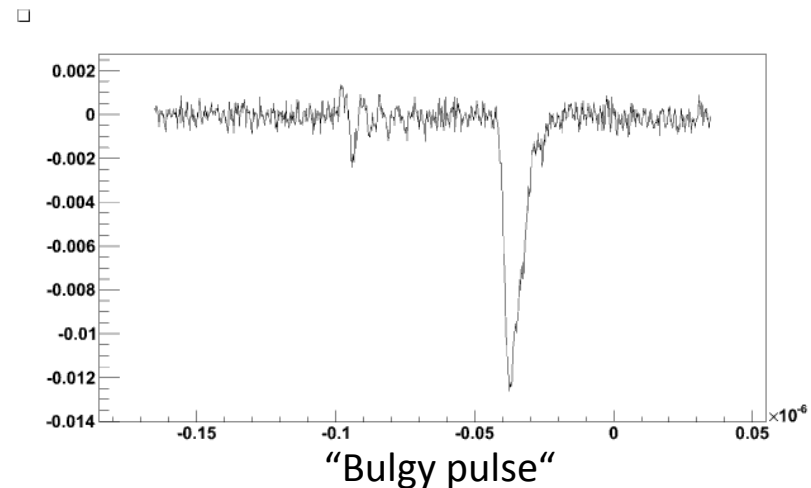
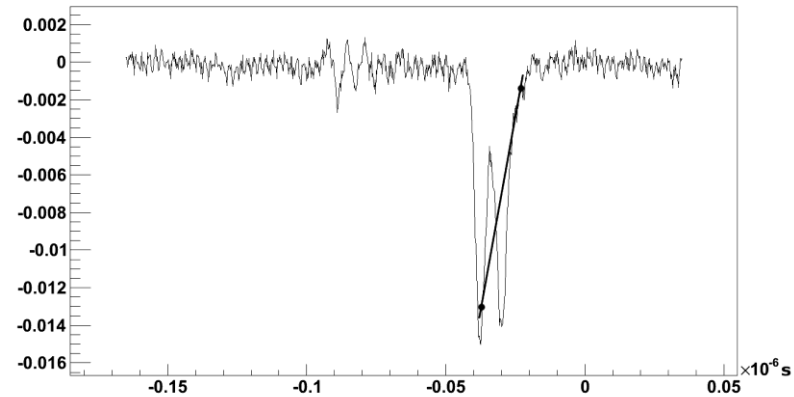


Fast Afterpulses (fAP):

Detection algorithms: Pulse shape

- Subtract pulse

- Principle: subtract expected pulse shape on falling flank \rightarrow fAP remain + can be found with simple threshold criterium
- Model used for pulse shape
 - Linear interpolation: reliable, but low recognition rate
 - Parabola: low detection rate, problems with pulses with \approx linear decay: “bulgy” pulses
 - Exponential decay: high recognition rate, but bulgy pulses filter through
 - Average pulse shape: same as exponential
- Choose higher threshold for exponential decay / average pulse form



Fast Afterpulses (fAP):

Detection algorithms: Pulse shape

- Search maximum/minimum

- Principle: fAP on falling flank produces an additional minimum + maximum

- Methods:

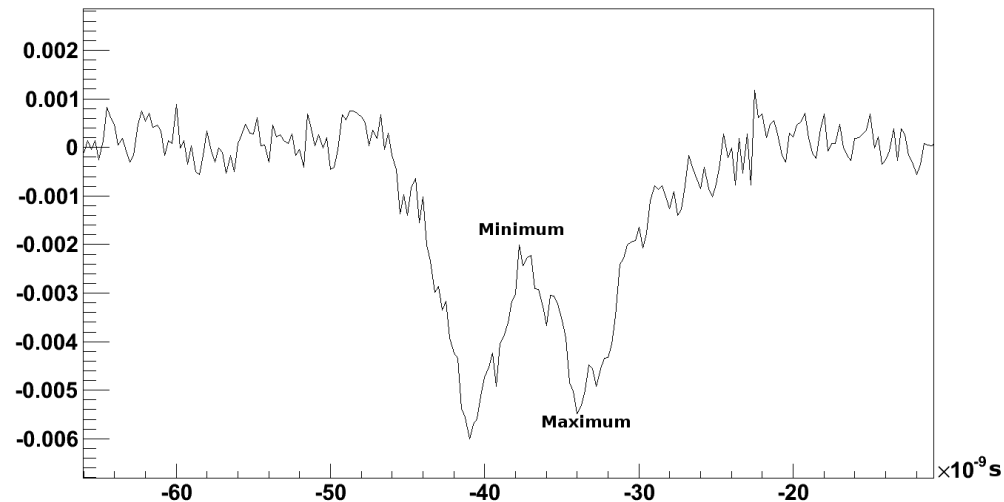
- Number of higher/lower points in interval around current point: bigger than threshold → extremum;

- prone to noise

- **Three intervals:** If maximum of interval 2 is bigger than maxima of interval 1+3 → peak found; more than one peak → fAP

- Works very good for intervals with >3ns window

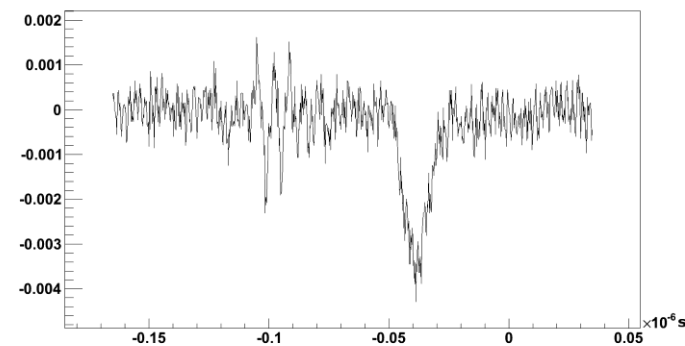
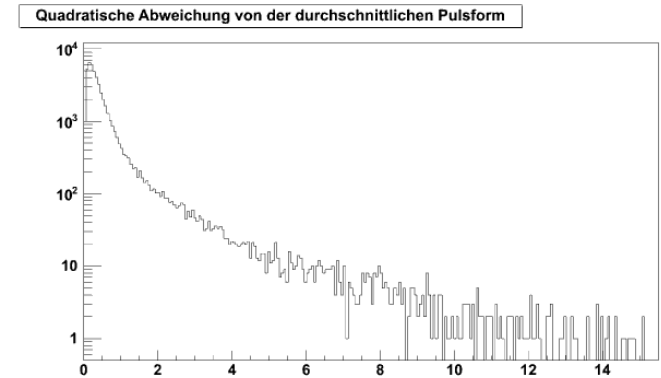
- Next step: include threshold for height difference between minimum and fAP peak to be able to use smaller windows → find more AP which are small or close to peak



Fast Afterpulses (fAP): Detection algorithms:

Pulse shape

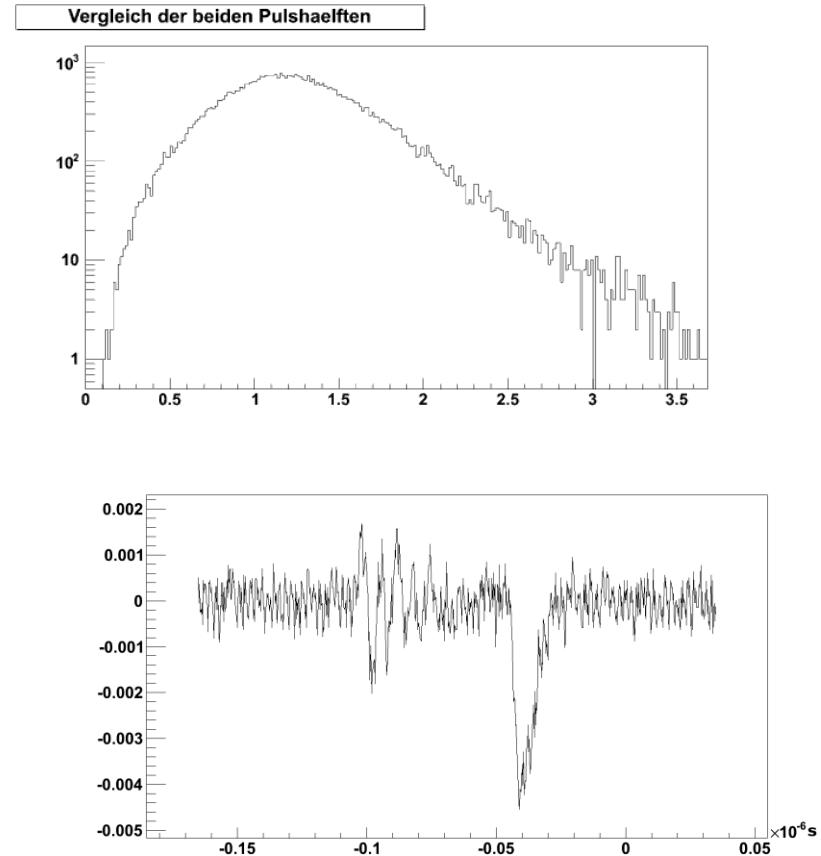
- Search for inflection points
 - Principle: fAP on falling flank produces two additional inflection points → two additional zero crossings in 2nd time derivative
 - Problems: up to now jitter from noise too strong
 - Conclusion: need to average over more points
- Quadratic difference from average pulse form
 - Principle: integrate squared difference of pulse shape to average pulse shape for each data point; fAP on flank produce irregular pulse shape → higher value
 - Problems:
 - Pulses with small heights apparently have different shape + vary more strongly due to noise
 - Conclusion: should be usable for high values, use separate average pulse form for small pulses



Fast Afterpulses (fAP): Detection algorithms:

Area

- Area ratio falling flank/rising flank
 - Principle: fAP on falling flank adds charge \rightarrow time integral over falling flank gets bigger
 - Problems:
 - Fake main pulses \rightarrow ratio too small
 - Bulgy pulses \rightarrow higher ratios
 - Conclusion:
 - Usable for large ratios
 - For fake main pulses: use as cross-check after other algorithm



Summary

- Pressure withstanding PMT encapsulations for LENA:
 - Have designed engineering drawings of first encapsulations in CAD + simulated them with FEA software; method established → now refine it
 - Results still very preliminary, need to construct complete optical module and optimize for weight + costs before comparisons between different designs are possible
 - First results look promising
- Fast afterpulse detection algorithms
 - Developed several algorithms, identified problems
 - Still optimizing to eliminate disturbing effects and increase detection rate
 - With only small adjustments and combined evaluation of two methods, most algorithms should improve substantially

References

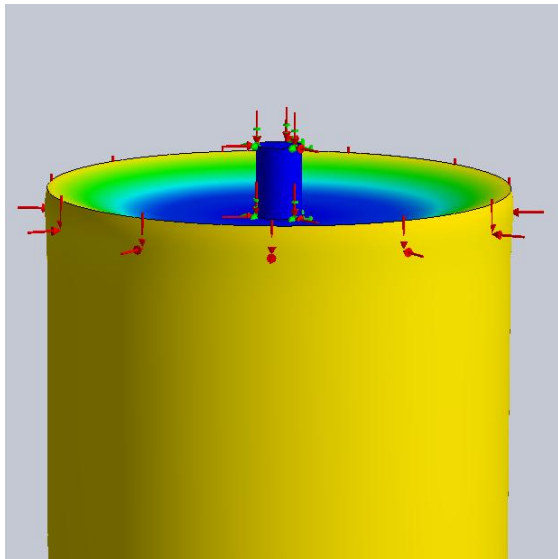
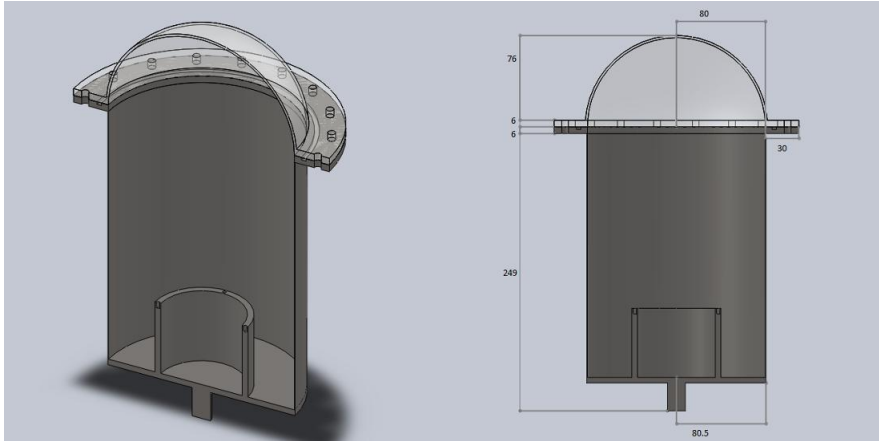
- For further information please refer to:
 - LENA White Paper, <http://arxiv.org/abs/1104.5620>
 - German Beischler, bachelor thesis, Technische Universität München, August 2011, http://www.e15.physik.tu-muenchen.de/fileadmin/downloads/thesis/bachelor/2011_BSc_German_Beischler.pdf
 - Martin Zeitlmair, bachelor thesis, Technische Universität München, July 2011, http://www.e15.physik.tu-muenchen.de/fileadmin/downloads/thesis/bachelor/2011_BSc_Martin_Zeitlmair.pdf

A 3D rendered scene featuring a tunnel of golden spheres. The spheres are arranged in a grid that recedes into the distance, creating a strong sense of perspective. The floor is a dark, reflective surface that mirrors the spheres and the light. The overall color palette is dominated by gold and dark grey/blue tones.

Backup slides

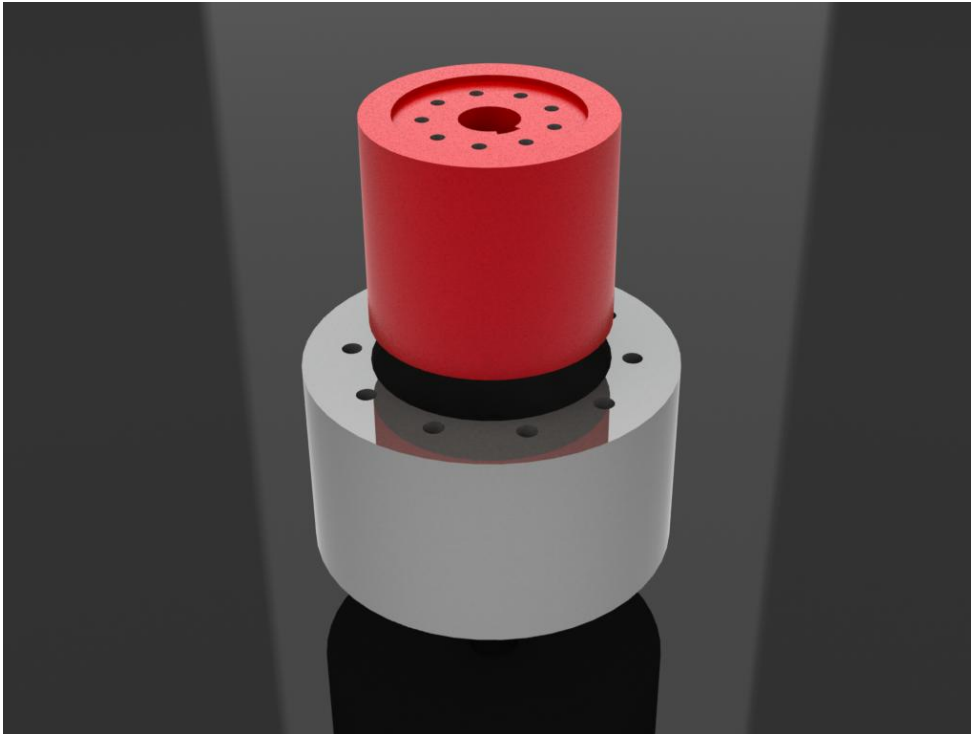
Cylindric encapsulation

Hamamatsu R6594



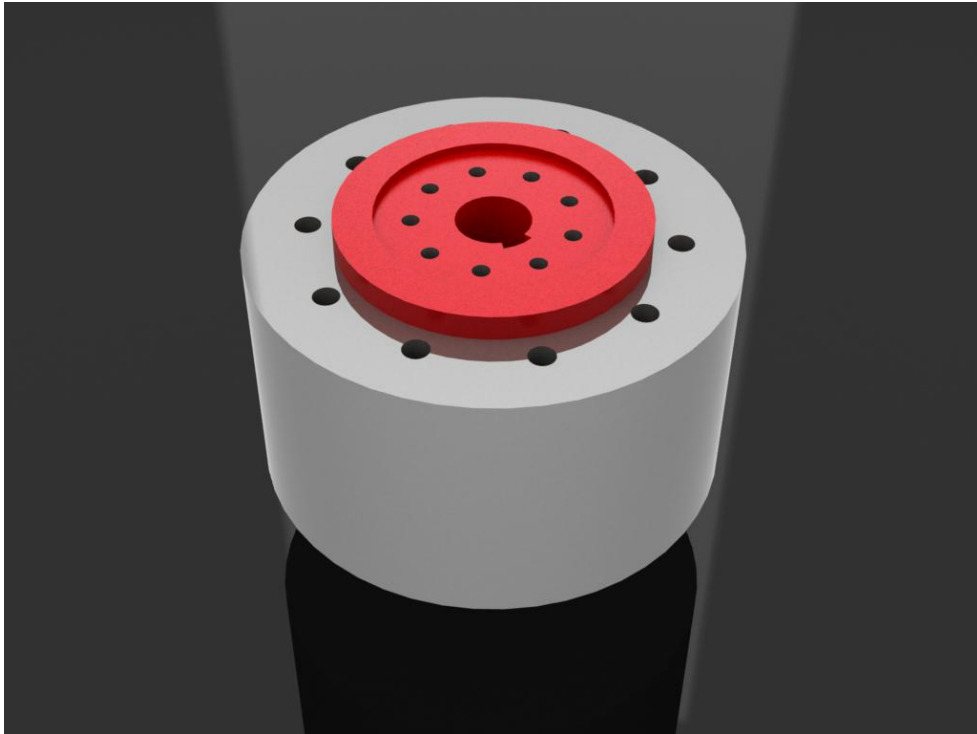
- Simple form
 - probably easy to produce + low costs
- Steel thickness 0.5mm
- Problem: floor was pushed in → tearing of side walls
 - First solution: enforced floor, however 5mm thickness needed
 - Optimize design: enforce walls in critical areas

Assembly of a R6594 conical encapsulation



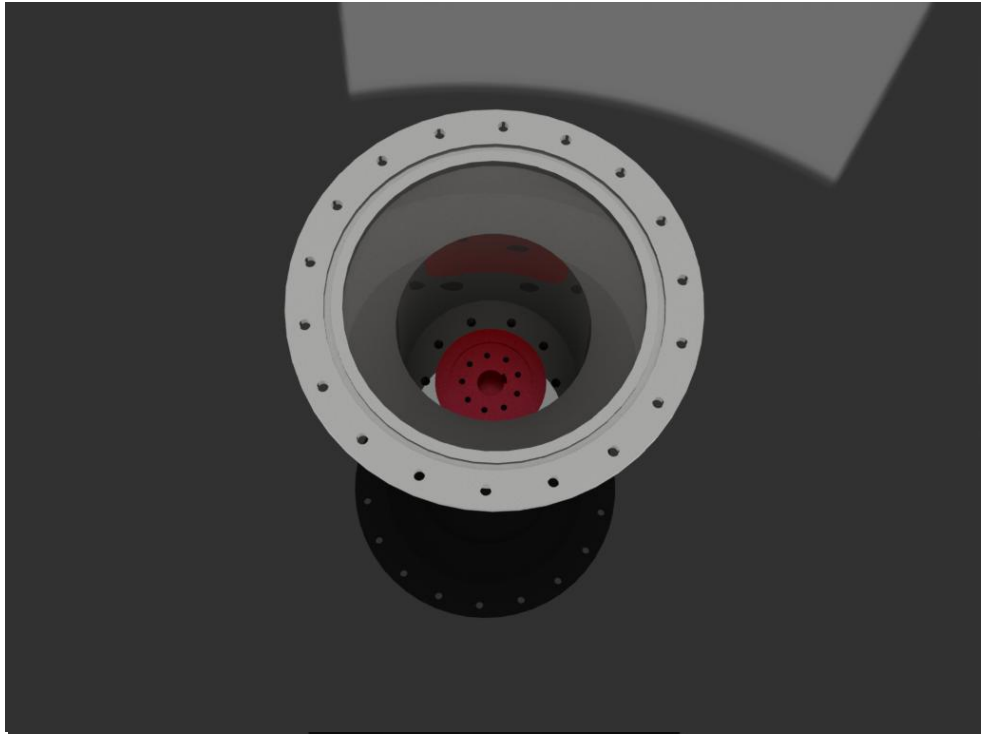
- Assembly sequence for conical encapsulation:
 1. Solder voltage divider circuit board to socket for PMT pins
 2. Insert into lower part of metal encapsulation / plastic housing
 3. Infuse polyurethane → fixes VD + socket
 4. Bolt down upper part of metal encapsulation + retaining ring to hold down PE
 5. Insert PMT into socket
 6. Attach acrylic glass window (using o-ring seal) + brackets connecting PMTs to modules and attaching them to the walls
 7. Fill up encapsulation with oil

Assembly of a R6594 conical encapsulation



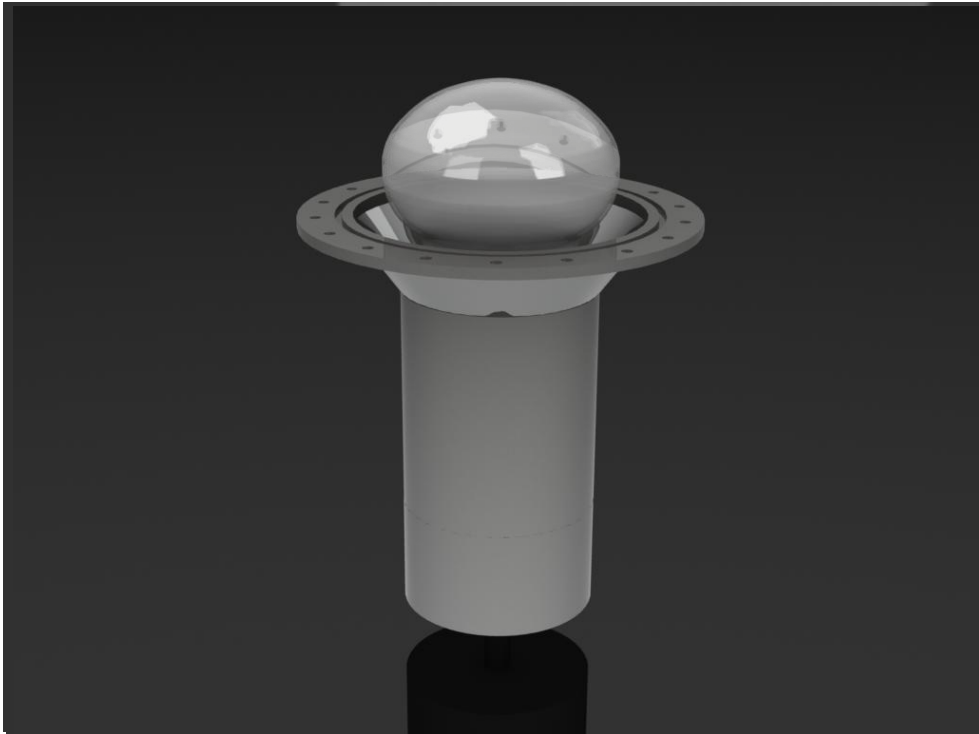
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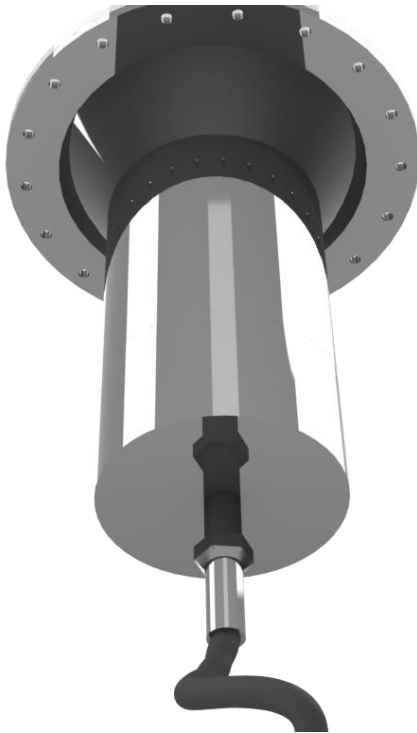
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Attachment to wall

